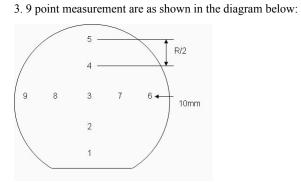
Icemos Technology Ltd Product Specification 1003.290401 Issue Date 10 July 2014 14:52:27

Part Number	Customer	

Category	Parameter		Specification	Measurement Method
OverallWafer	1.0	Diameter	150.00 +/- 0.50 mm	WaferVendor
	2.0	Primary Flat Length	57.50 +/- 2.50 mm	Wafer Vendor
	3.0	Primary Flat Orientation	{110}+/-1 degree	Wafer Vendor
	4.0	Growth Method	CZ	Wafer Vendor
	5.0	Туре	Any	Wafer Vendor
	6.0	Dopant	Any	Wafer Vendor
	7.0	Resistivity	0.1~ 100 ohm cm	Wafer Vendor
	8.0	Overall Thickness	650.00 +/- 25.00 um	Wafer Vendor
	9.0	Total Thickness Variation (TTV)	<3.00um	Guaranteed by process
	10.0	Bow	<50.00um	ADE to ASTM F534, 20%
	11.0	Warp	<50.00um	ADE to ASTM F657, 20%
	12.0	Lasermarking	On wafer FRONTSIDE opposite the flat as per attachment. Scribe format: [ICE-6-650.XXXX] (unique scribe)	Guaranteed by process
	13.0	Orientation	<100> +/-0.5	Wafer Vendor
	14.0	Back Surface Quality	Polished with light handling marks.	Guaranteed by process
	15.0	Front Surface Quality	Prime polished	Guaranteed by process
	16.0	Edge Chips	None	Bright Light 100% (note 2)
HandleSilicon	17.0	Handle Thickness	650.00 +/- 25.00 um	ADE
	18.0	Surface Haze	None	Bright Light, 100% (note 2).
	19.0	Total scratch length	None	Bright Light, 100% (note 2).

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icemos i cemnology	Etu 1	Todact Specification	1005.270401	133uc Date	10 July 2014 14.52:27
Part Number		Customer			
Category	Parameter	Specification		Me	easurement Method
Shipping Details	Wafer per box :	Max 25			
	Packaging:	Taped Polypropylene Wafer B Empak, Ultrapak, 150.00mm Antistatic Double Bagging	ox		
	Lot Shipment Data	Device Thickness Bow / Warp Data Handle and SOI Thickness			
Explanatory Notes	1. Microscope inspec	tion performed using microscope s	scan as below. 5x objec	tive.	
		pections performed exclude all was	-		d in Overall



Additional Information